

IDS - 09/26/2006

FORM PTO/SB/08A/B (10-01)
Substitute for PTO-1449A/B**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

SEP 26 2006

Attorney Docket Number

50736/Y35

Application Number

10/656,086

Filing Date

September 5, 2003

Applicant(s)

Yong-Chul Park, et al.

Group Art Unit

1745

Examiner Name

Laura S. Weiner

U.S. PATENT DOCUMENTS

EXAMINER INITIALS	Cite No. ¹	DOCUMENT NUMBER Number - Kind Code ² (If Known)	PUBLICATION DATE MM-DD-YYYY	NAME OF PATENTEE
LW		5,709,968	01-20-1998	Shimizu
LW		5,879,834	03-09-1999	Mao
LW		6,146,790	11-14-2000	Omaru et al.

FOREIGN PATENT DOCUMENTS

EXAMINER INITIALS	Cite No. ¹	Foreign Patent Document Country Code ³ - Number ⁴ - Kind Code ⁵ (If Known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	⁶ (✓)
LW		JP 2000-106209	04-11-2000	Hayashi et al.	Patent Abstracts of Japan
LW		JP 11-329496	11-30-1999	Hayashi et al.	Patent Abstracts of Japan
LW		JP 2001-223024	08-17-2001	Kin et al.	Patent Abstracts of Japan
LW		JP 10-189044	07-21-1998	Komaru et al.	Patent Abstracts of Japan

OTHER DOCUMENTS

EXAMINER INITIALS	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
LW		Patent Abstracts of Japan, Publication No. 2000-106209; Publication date 04-11-2000; in the name of Hayashi et al.
LW		Patent Abstracts of Japan, Publication No. 11-329496; Publication date 11-30-1999; in the name of Hayashi et al.
LW		Patent Abstracts of Japan, Publication No. 2001-223024; Publication date 08-17-2001; in the name of Kin et al.
LW		Patent Abstracts of Japan, Publication No. 10-189044; Publication date 07-21-1998; in the name of Komaru et al.

GL PAS701715.1 *-09/20/06 4:21 PM

EXAMINER SIGNATURE	/Laura Weiner/	DATE CONSIDERED	11/01/2006
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.pto.gov or MPEP 901.4. ³ Enter Office that issued the document, by the two-letter code (WIPO standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English Language Translation is attached.			

Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

DAP/gf